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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	08/818,884
				Filing Date	March 17, 1997
				First Named Inventor	Shunpei YAMAZAKI et al.
				Group Art Unit	2871
				Examiner Name	D. Nguyen
Sheet	1	of	1	Attorney Docket Number	0756-1653

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
DN		5,616,944		Mizutani et al.	04/01/1997	—
DN		5,851,440		Tanaka et al.	12/22/1998	—
DN		4,743,567		Pandya et al.	05/10/1988	—
DN		5,514,879		Yamazaki	05/07/1996	—

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
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DN		M.K. HATALIS et al., <i>High-Performance Thin-Film Transistors in Low-Temperature Crystallized LPCVD Amorphous Silicon Films</i> , IEEE Electron Device Letters. Vol. 1, EDL8, No. 8, August, 1987, Pages 361-364.	

Examiner Signature	D. NGUYEN	Date Considered	05/18/06
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